

INFORMATION DISCLOSURE STATEMENT

Applicant	: Arjen Storm et al.
App. No.	: Unknown
Filed	: Herewith
For	: METHOD AND DEVICE FOR HEAT TREATING SUBSTRATES
Examiner	: Unknown
Group Art Unit	: Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing 32 references that are of record in U.S. patent application No. 10/151,207, filed May 16, 2002, which is the parent of this Divisional application, and is relied upon for an earlier filing date under 35 U.S.C. § 120. Copies of the references are not submitted pursuant to 37 C.F.R. § 1.98(d).

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required in accordance with 37 C.F.R. § 1.97(b)(3). If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 4-13-04

By: Rabinder N. Narula

Rabinder N. Narula
Registration No. 53,371
Attorney of Record
Customer No. 20,995
(949) 760-0404

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)	ATTY. DOCKET NO. NEDER29.001DV1	APPLICATION NO. Unknown
	APPLICANT Arjen Storm et al.	
	FILING DATE Herewith	GROUP Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	1	4,495,024	01/22/85	Bok			
	2	4,560,590	12/24/85	Bok			
	3	4,575,408	03/11/86	Bok			
	4	4,860,687	08/29/89	Frijlink			
	5	4,975,561	12/04/90	Robinson et al.			
	6	5,314,848	05/24/94	Yasui et al.			
	7	5,332,442	07/26/94	Kubodera et al.			
	8	5,414,244	05/1995	Imahashi			
	9	5,430,271	07/04/95	Orgami et al.			
	10	5,650,082	07/22/97	Anderson			
	11	5,790,750	08/04/98	Anderson			
	12	6,018,616	01/25/00	Schaper			
	13	6,064,799	05/16/00	Anderson et al.			
	14	6,072,163	06/2000	Armstrong et al.			
	15	6,080,969	06/27/00	Goto et al.			
	16	6,097,005	08/01/00	Akimoto			
	17	6,111,225	08/29/00	Ohkase et al.			
	18	6,183,565	02/06/01	Granneman et al.			
	19	6,207,936	03/27/01	De Waard et al.			
	20	6,234,788	05/2001	Lee			
	21	6,275,744	08/2001	Yshida			
	22	6,329,304	12/11/01	Kuznetsov et al.			
	23	2003-0209327 A1	05/08/02	Kuznetsov et al.			

EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	

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		FILING DATE Herewith	GROUP Unknown

FOREIGN PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	24	08236533	09/13/96	EP				
	25	10321505	12/04/98	EP				
	26	00/42638	07/20/00	WO				
	27	00/68977	11/16/00	WO				
	28	JP 402034915 A	02/05/90	Japan				
	29	JP 404078310 A	03/12/92	Japan				
	30	JP 361294812 A	12/25/86	Japan				
	31	JP 362021237 A	01/29/87	Japan				

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)							
	32	Porter et al., "Fast-ramp rapid vertical processor for 300-mm Si wafer processing". SPIE vol 3507, September 1998, p 42-53.						

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